

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : Shunji MAEDA *et al.*  
Serial No. : Unassigned (§53(b) Cont. of 10/098,478 filed 18 March 2002)  
Filed : 17 October 2003  
For : MANUFACTURING METHOD OF SEMICONDUCTOR  
SUBSTRATE AND METHOD AND APPARATUS FOR  
INSPECTING DEFECTS OF PATTERNS OF AN  
OBJECT TO BE INSPECTED  
Art Unit : Unassigned (Parent - 2877)  
Examiner : Unassigned (Parent - Hoa Q. Pham)  
Conf. No : Unassigned (Parent - 5054)

**INFORMATION DISCLOSURE STATEMENT**

**Mail Stop Patent Application**  
Commissioner for Patents  
POB 1450  
Alexandria, Virginia 22313-1450

17 October 2003

Sir:

In the matter of the above-identified application, Applicant hereby submits the attached information for consideration by the Office under 37 C.F.R. §§1.97 and 1.98 in the present application and for printing on the face of any patent issuing hereon, as listed on the attached Form PTO-1449.

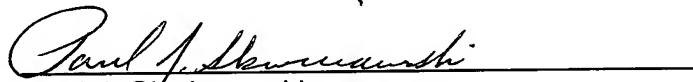
The present application is a continuation of Appln. No. 10/097,478 filed 18 March 2002, pending, which is a continuation of Appln. No. 09/588,201 filed 6 June 2000, now US 6,404,498 B1, which is a continuation of Appln. No. 09/107,432 filed 30 June 1998, now US 6,263,099, which is a continuation of Appln. No. 08/539,886 filed 6 October 1995, now US 5,774,222. The information listed on

the attached Form PTO-1449 was previously cited by or submitted to the Office in the prior applications. Therefore, no copies of the listed references are required, in accordance MPEP §609A(2). Further, in accordance with MPEP §609A(3), no concise explanation of relevance is required for the information that is not in the English language because the relevance of the information does not differ from its relevance as explained in the prior applications.

This Information Disclosure Statement is submitted concurrently with the above-identified continuation, and is therefore timely, so no Petition or fee is required for this submission.

The Examiner is respectfully requested to return an initialed copy of the Form PTO-1449 to indicate entry and consideration of the information listed thereon.

Respectfully submitted,

  
\_\_\_\_\_  
Paul J. Skwierawski  
Registration No. 32,173  
ANTONELLI, TERRY, STOUT & KRAUS, LLP  
1300 North Seventeenth Street, Suite 1800  
Arlington, VA 22209-3801  
Telephone 703-312-6600  
Facsimile 703-312-6666

**ATTACHMENT:**  
Form PTO-1449

FORM PTO-1449 U.S. Department of Commerce (Rev. 4/92) Patent and Trademark Office		ATTY. DOCKET NO. 501.33745CX4	SERIAL NO. §53b of 10/098,478
INFORMATION DISCLOSURE STATEMENT BY APPLICANT		APPLICANT Shunji MAEDA <i>et al.</i>	
(Use several sheets if necessary)		FILING DATE 17 October 2003	GROUP Unassigned

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	5,699,447	12/97	Alumot <i>et al.</i>			
	5,085,517	2/92	Chadwick <i>et al.</i>			
	5,479,252	12/95	Worster <i>et al.</i>			
	5,131,755	7/92	Chadwick <i>et al.</i>			
	4,999,014	3/91	Gold <i>et al.</i>			
	4,877,326	10/89	Chadwick <i>et al.</i>			
	5,897,710	4/99	Sato <i>et al.</i>			
	5,963,314	10/99	Worster <i>et al.</i>			
	4,299,443	11/81	Minami <i>et al.</i>			
	4,725,722	02/88	Maeda <i>et al.</i>			
	5,377,002	12/94	Matin <i>et al.</i>			

## FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
	3-153054		JP				
	4-311053	11/92	JP				
	5-006928	1/93	JP				
	6-275696	9/94	JP				
	6-194402	7/94	JP				

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER \_\_\_\_\_ DATE CONSIDERED \_\_\_\_\_

EXAMINER: Initial if citation is considered, draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.